

**RESPONSE UNDER 37 C.F.R. § 1.116
EXPEDITED PROCEDURE REQUESTED
EXAMINING GROUP 1794
PATENT**
Attorney Docket No. 01165.0933

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
Yuichi Komuro et al.)
Application No.: 10/520,666) Group Art Unit: 1794
Filed: January 10, 2005)
For: Wiper Method and Manufacturing) Examiner: Peter Y. Choi
) Confirmation No.: 9409
) Mail Stop AF
)

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

AMENDMENT AFTER FINAL

In reply to the Final Office Action mailed November 9, 2007, **the period for response having been extended to March 9, 2007 (a Sunday) by a request for extension of one month and fee payment filed concurrently herewith**, and pursuant to 37 C.F.R. § 1.116, Applicants propose that this application be amended as follows:

Amendments to the Claims are reflected in the listing of claims in this paper.

Remarks/Arguments follow the amendment section of this paper.